TED STATES PATENT AND TRADEMARK OFFICE

In re Application of

iiAR 18 2082

TECHAULUSY CENTER 2800

Yutaka Kobayashi

Serial No.: 09/893,791

Group Art Unit: 2815

Filed: June 29, 2001

Examiner: Chris C. Chu

For:

SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING SAME

Honorable Assistant Commissioner of Patents Washington, D.C. 20231

RESPONSE TO FIRST OFFICE ACTION AND RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated February 20, 2002, please consider the following:

REMARKS

In response to the Examiner's restriction requirement, Applicant hereby elects the invention of Group I (e.g., drawn to a semiconductor device as defined by claims 1-4), without traverse. Applicant reserves the opportunity to file a Divisional Application for the nonelected invention later.

Further, Applicant respectfully requests the Examiner's acknowledgment of the priority document filed on June 29, 2001.

Early, favorable prosecution on the merits is respectfully requested.

Should the Examiner find the application to be other than in condition for allowance the Examiner is requested to contact the undersigned at the local telephone number listed below to discuss any other changes deemed necessary in a telephonic or personal interview. 09/893,791 PNDF-01068

A conditional petition is made for any extension of time which may become necessary.

The Commissioner is authorized to charge any fees for such extension and to credit any overpayment in fees to Attorney's Deposit Account No. 50-0481.

Respectfully Submitted,

Sean M. McGinn Reg. No. 34,386

Date: March 15, 2002 McGinn & Gibb, PLLC 8321 Old Courthouse Road, Suite 200 Vienna, Virginia 22182-3817 (703) 761-4100 Customer No. 21254